

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL PATENT APPLICATION OF

Inventor(s): FUKAURA, Yasuhiro

Filed: Herewith

Title: METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE WITH GLUE LAYER IN OPENING

June 24, 2003

**PRELIMINARY AMENDMENT (Revised Format)**

Mail Stop Patent Applications  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to the examination on the merits, please amend this application as follows:

**IN THE TITLE:**

Please change the title as follows:

~~SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE SUPPRESSING A~~  
~~JUNCTION LEAK AND METHOD OF MANUFACTURING THE SAME~~  
SEMICONDUCTOR DEVICE WITH GLUE LAYER IN OPENING